[10191/1728]

## <u>IN THE UNITED STATES PATENT AND TRADEMARK OFFICE</u>

ventors

GROSSE et al.

Confirmation No.: 9967

Serial No.

09/831,722

Filed

September 6, 2001

For

DEVICE AND METHOD FOR PRODUCING

A LOCAL PLASMA THROUGH MICROSTRUCTURE ELECTRODE DISCHARGES USING MICROWAVES

Examiner

E. Fuller

Art Unit

1762

Customer No.

26646

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Date

Atty's Reg. # 41.172

Atty's Signature

DERVIS MAGISTRE KENYON & KENYON

## **AMENDMENT**

SIR:

In response to the Office Action of May 31, 2005, kindly amend the above-captioned application as follows:

Amendments to the Specification do not appear this paper.

Amendments to the Claims are reflected in the listing of the claims which begins on page 2 of this paper.

Amendments to the Drawings do not appear this paper.

Remarks begin on page 7 of this paper